

INFORMATION DISCLOSURE CITATION IN AN APPLICATION						ATTY. DOCKET NO. 050395-0243		SERIAL NO. 10/750,864			
(PTO-1449)						APPLICANT Masaaki HIRANO, et al.					
						FILING DATE January 05, 2004		GROUP 1731			
U.S. PATENT DOCUMENTS											
EXAMINER'S INITIALS		CITE NO.	Document Number Number-Kind Code ₂ (if known)		Publication Date MM-DD-YYYY		Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
/QSD/			US 2002/0102083		08/01/2002		Berkey et al.				
/QSD/			US 6,131,415		10/17/2000		Chang et al.		Corresponding to CN 1221709		
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FOREIGN PATENT DOCUMENTS											
EXAMINER'S INITIALS		CITE NO.	Foreign Patent Document Country Codes -Number & -Kind Codes (if known)		Publication Date MM-DD-YYYY		Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No	
/QSD/			CN 1221709		07/07/1999		-----		Corresponds to US 6,131,415		
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
EXAMINER'S INITIALS		CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.								
			Office Action dated December 1, 2008								
EXAMINER /Queenie Dehghan/						DATE CONSIDERED 04/13/2007					

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

INFORMATION DISCLOSURE CITATION IN AN APPLICATION



(PTO-1449)

 ATTY. DOCKET NO.
50395-243

 SERIAL NO.
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 APPLICANT
Masaaki HIRANO, et al.

 FILING DATE
January 05, 2004

 GROUP
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U.S. PATENT DOCUMENTS

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/QSD/	A1	US 2002/0102083	08/01/2002	Berkey et al.	
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FOREIGN PATENT DOCUMENTS

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						Yes	No
/QSD/	A2	EP 0 718 244	06/26/1996	Coming Incorporated			
/QSD/	A2	EP 0 887 670	12/30/1998	Lucent Technologies Inc.			
/QSD/	A1	WO 02/060830	08/08/2002	Ministry of Information Technology			
/QSD/	A1	WO 02/098806	12/12/2002	Coming Incorporated			

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

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/Queenie Dehghan/

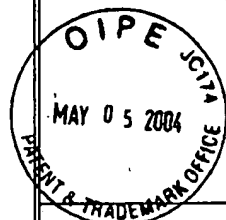
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/QSD/		US 5,917,109	06/29/1999	Berkey	
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/QSD/		US 2002/0134113 A1	09/26/2002	Berkey	
/QSD/		US 4,793,842	12/27/1988	Yokota et al.	
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/QSD/		US 4,772,303	09/20/1988	Kamiya et al.	

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						Yes	No
/QSD/		JP 08-225335	09/03/1996		w/ corresponding EP 0718 244 A2, U.S. patent 5,917,109, U.S. patent 6,422,042 B1 & U.S. Patent Appl. Publication 2002/0134113 A1		X
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/QSD/	A	JP 62-226829	10/05/1987	FURUKAWA ELECTRIC CO LTD		(w/ English Translation Abstract)	
/QSD/	A	JP 62-59543	03/16/1987	MITSUBISHI CABLE IND LTD		(w/ English Translation Abstract)	
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/QSD/	A	JP 61-227938	10/11/1986		w/ corresponding U.S. patent 4,793,842		
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
/QSD/		Hajumu Wakabayashi, et al., "DIFFUSION OF WATER INTO SILICA GLASS AT LOW TEMPERATURE", Materials Engineering Department, Rensselaer Polytechnic Institute, Troy, New York 12180-3590, J. Am. Ceram. Soc., Vol. 72, No. 10, pp. 1850-1855
/QSD/		Application handbook for amorphous silica materials (compiled by Katsuro Fukamizu, published by Realize Co., 1999, pp. 54-69 and partial English Translation thereof

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